| Bay 1 Tool | Process Engineer | Technician/Backup | Bay 2 Tool | Process Engineer | Technician/Backup | Bay 3 Tool | Process Engineer | Technician/Backup |
| :---: | :---: | :---: | :---: | :---: | :---: | :---: | :---: | :---: |
| TD03 Parylene Coater | Audrey | $\frac{\text { Scott }}{}$ | Karl Suss \#1/\#2 | Alexandra/Audrey | John | PE03 ICP-Metal Etch | Audrey | Scott |
| Tystar LPCVD | Audrey | Bruce | HS02 Solvent Hood | Audrey | John | PE04 Dielectric/DSE Etch | Audrey | Bruce |
| TC01 Cambridge ALD | Audrey | Scott | DM01 Leica 200 Microscope | Alexandra/Audrey | John | PE05 III-V Etch | Audrey | Bruce |
| ALD Ozone Generator | Audrey | Scott | Hot Plates | Alexandra/Audrey | John | PD01, PD02 PECVD | Alexandra | Scott |
| TR02 RTP1 | Audrey | Scott | Ovens | Alexandra/Audrey | John | PD03 PECVD | Alexandra | Scott |
| TR03 RTP2 | Audrey | Scott | TV01 Vacuum Oven | Alexandra/Audrey | John | MS04 AJA Orion | Audrey | Zane |
| Tystar Oxidation Furnace | Audrey | Scott | $\frac{\text { Acid/Base and Solvent CPK }}{\text { DWL Mask Writer }}$ | Alexandra/Audrey | John | MS03 AJA 1500 | Audrey | Zane |
| TO01 Oven | John | John | CEE Spinner | Alexandra/Audrey | John | ME03 Temescal | Audrey | Zane |
| Minibrute Furnaces | Audrey | Scott | Headway Spinner | Alexandra/Audrey | John | ME02 Cryo Evap | Audrey | Zane |
|  |  |  | Mask Washer | Alexandra/Audrey | John | Trion RIE | Alexandra | John |
|  |  |  | TC03 PE-ALD | Audrey | Scott | March Asher | Alexandra | John |


| Bay 4 Tool | Process Engineer | Technician/Backup |
| :--- | :---: | :---: |
| HA01 Acid Hood | Audrey | John |
| HB01 Base Hood | Audrey | John |
| HR01 RCA Hood | Audrey | John |
| HS01 Solvent Hood | Audrey | John |
| MP01 CHA | Audrey | Zane |
| CD02 Spin/Rinse/Dry | Audrey | John |
| CD03 Critical Pt Dryer | Zane | John |
| AJA \#3 | Alexandra | Zane |


| Bay 5 Tool | Process Engineer | Technician/Backup |
| :--- | :---: | :---: |
| AFM | Audrey | Rep |
| LI01 Nanolmprint | Hu Reseach Group | Bruce |
| Raith 150 EBL | Alexandra | Rep |
| DM07 Zeiss SEM | Alexandra | Rep |
| DS01 Toho Film Stress | Alexandra | Alexandra |
| DektakXT Profilometer | Alexandra/Audrey | Alexandra/Audrey |
| MS02 Hummer IV Sputter | Alexandra/Audrey | John |
| DP03 Alessi 4 pt probe | Alexandra/Audrey | John |
| DP04 Jandel 4 pt probe | Alexandra/Audrey | John |
| DT05 Nanospec | Alexandra/Audrey | Alexandra/Audrey |
| DA01 FTIR | Alexandra | Alexandra |
| DM05 Leica100 microscope | Alexandra/Audrey | John |
| Goniometer | Audrey | Audrey |
| Ellipsometer | Alexandra/Audrey | Scott |

Updated March 1, 2022

